

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 25, 2025

IGI Report Number

LG700575846

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

6.76 X 4.71 X 3.19 MM

GRADING RESULTS

Carat Weight

1.02 CARAT

Color Grade

E

Clarity Grade

SI 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

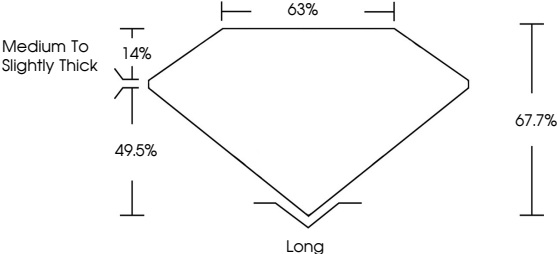
Inscription(s)

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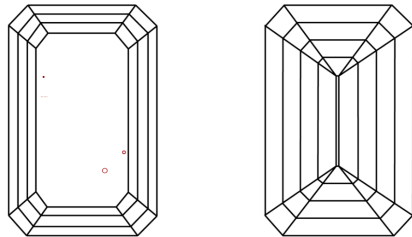
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS <sup>1-2</sup> VS <sup>1-2</sup> SI <sup>1-2</sup> I <sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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Carat Weight

1.02 CARAT

Color Grade

E

Clarity Grade

SI 1

Depth

49.5%

Table

14%

Girdle

Medium to Slightly Thick

Culet

Long

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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